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Electronic Version v05

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<b>Title of Invention</b>	METHOD FOR FABRICATING A THROUGH HOLE ON A SEMICONDUCTOR SUBSTRATE
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First Named Applicant :

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Attorney Docket Number :

LKSP0036USA

I hereby appoint the registered practitioner(s) at Customer Number:

027765



as attorney(s) or agent(s) to prosecute the application identified above, and to transact all business in the United States Patent and Trademark Office connected therewith.

I am the Applicant/Inventor.

Full Name of Applicant of Record:

Winston Hsu

Signature: Winston Hsu

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